



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
www.uspto.gov

BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 3460

SERIAL NUMBER 10/822,820	FILING DATE 04/13/2004 RULE	CLASS 438	GROUP ART UNIT 2825	ATTORNEY DOCKET NO. 0756-7290
-----------------------------	---------------------------------------	--------------	------------------------	-------------------------------------

APPLICANTS

Misako Nakazawa, Tochigi, JAPAN;

Toshiji Hamatani, Atsugi, JAPAN;
Naoki Makita, Nara, JAPAN;

**** CONTINUING DATA** *****
 This application is a DIV of 10/229,385 08/28/2002 PAT 6,734,050

**** FOREIGN APPLICATIONS** *****
 JAPAN 2001-261695 08/30/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
**** 06/23/2004**

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 16	TOTAL CLAIMS 32	INDEPENDENT CLAIMS 5
Verified and Acknowledged Examiner's Signature	Initials				

ADDRESS
 31780
 ERIC ROBINSON
 PMB 955
 21010 SOUTHBANK ST.
 POTOMAC FALLS , VA
 20165

TITLE
 Crystalline semiconductor film, method of manufacturing the same, and semiconductor device

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other <input type="checkbox"/> Credit
RECEIVED 1158		